

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Div. Application of 09/704,563 of:

Junichi Hikita

Application No.: 10/626,524

Filed: July 25, 2003

For: METHOD OF PRODUCING A SEMICONDUCTOR DEVICE BY DIVIDING A SEMICONDUCTOR WAFER INTO SEPARATE PIECES OF SEMICONDUCTOR CHIPS

Examiner: William D. Coleman

Art Unit: 2823

Confirmation No. 1133

**ASSOCIATE POWER OF ATTORNEY AND  
NOTIFICATION OF CHANGE OF NAME AND ADDRESS**

Commissioner for Patents  
Alexandria, VA 22313

Sir:

The undersigned, the attorney of record in connection with the above-identified application, hereby grants and appoints as associate attorneys to conduct all business before the United States Patent and Trademark Office relative to said application:

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Respectfully submitted,

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